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Bib Data Sheet

CONFIRMATION NO. 5100

SERIAL NUMBER 10/802,806	FILING DATE 03/18/2004 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 021740A
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** CONTINUING DATA *****

This application is a DIV of 10/351,385 01/27/2003 PAT 6,998,330

** FOREIGN APPLICATIONS *****

JAPAN 2002-022631 01/31/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/03/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN	2	2	2
Examiner's Signature	Initials			

ADDRESS

23850

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TITLE

Manufacturing apparatus for buried insulating layer-type semiconductor silicon carbide substrate

☐ All Fees